**Patent** 

Case No.: 58392US002

4078

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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

First Named Inventor:

Fan, Xudong

Application No.:

10/685208

Confirmation No.:

Filed:

October 14, 2003

Title:

POROUS MICROSPHERE RESONATORS

## SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Mail Stop: Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 CERTIFICATE OF MAILING OR TRANSMISSION [37 CFR § 1.8(a)]

I hereby certify that this correspondence is being:

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Dear Sir:

Pursuant to 37 CFR §§ 1.56, 1.97, and 1.98, enclosed is a completed Form PTO-1449, citing references submitted for consideration by the Examiner. It is respectfully requested that the Examiner initial and return the enclosed Form PTO-1449 to indicate that each reference has been considered.

Copies of any cited foreign patents, foreign publications, non-patent literature documents, and any pending U.S. applications filed before June 30, 2003, are enclosed. Copies of any pending U.S. applications filed after June 30, 2003 that can be accessed on the USPTO's IFW system are not enclosed as per USPTO Waiver dated September 21, 2004. Copies of any U.S. patents and published U.S. patent applications are not enclosed.

This Information Disclosure Statement is being mailed after receipt of a first Office Action on the merits, but prior to the mailing of a Notice of Allowance under 37 CFR § 1.311.

## Fees:

$\boxtimes$	Please charge the fee provided in 37 CFR § 1.17(p) to Deposit Account No. 13-3723.
One copy o	f this sheet marked duplicate is also enclosed.
	Any required fee will be paid at the time of EFS-Web submission.
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Respectfully submitted,

(1) Oct 1006

Date

William D. Miller, Reg/No.: 37,988

Telephone No.: 651-733-6649

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Substitute for form 1449A/PTO (modified)

## INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

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Application Number	10/685208		
Filing Date	October 14, 2003		
First Named Inventor	Fan, Xudong		
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U.S. Patent Documents						
Exam.	Cite	Document Number	Publication Date	Name of Patentee	Pages, Columns, Lines, Where Relevant Passages or Relevant	
Init.*	No.	Doc. Number-(Kind Code if Known)	MM-DD-YYYY	or Applicant of Cited Document	Figures Appear	
	A1	US- 6,865,317	03/08/2005	Vahala et al.		
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	A11	US-				
	A12	US-				

	Foreign Patent Documents						
Exam. Init.*	Cite No.	Foreign Patent Document		Publication Date	Name of Patentee or	Pages, Columns, Lines, Where Relevant Passages	Translation
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	B1						
	B2						
	В3						
	B4						
	B5						

	OTHER DOCUMENTS					
Exam. Init.*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	Translation (Check if yes)			
	C1	CHAN, S., et al. "Porous Silicon Microcavities for Biosensing Applications," <i>Physical Status Solid</i> , Vol. 182, (2000) pp. 541-546.				
	C2	DE STEFANO, L., et al., "Optical Sensing of Flammable Substances Using Porous Silicon Microcavities," <i>Materials Science and Engineering</i> , Vol. 100, July 25, 2003, pp. 271-274.				
	C3	MULLONI, V., et al. "Porous Silicon Microcavities as Optical Chemical Sensors," <i>Applied Physics Letters</i> , Vol. 76, No. 18, May 1, 2000, pp. 2523-2525.				

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